

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Eric Bornstein
Application Serial No.: 10/649,910
Filing Date: 26 August 2003
Title: NEAR INFRARED MICROBIAL ELIMINATION LASER
SYSTEM
Examiner: Jastrzab, Krisanne Marie
Art Unit: 1744
Atty. Docket No.: 072287-0019
Confirmation No.: 5770

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Date: 13 October 2006


Erin Olson

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT - ELECTION WITH TRAVERSE

This paper is in response to the Office Action dated 02 October 2006, with included restriction requirement, for the above-identified application.

The Applicant requests that subject application be amended in accordance with the following:

- **Amendments to the Claims**, as listed in the listing of claims beginning on page 2 of this paper; and
- **Remarks**, beginning on page 6 of this paper.